

Docket No.: 070759-0042

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
Yasuhiro WATANABE, et al. :
Application No.: Not yet assigned : Group Art Unit: Not yet assigned
Filed: December 14, 2006 : Examiner: Not yet assigned
For: SEMICONDUCTOR LASER DEVICE AND MANUFACTURING METHOD
THEREOF

PRELIMINARY AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to examination of the above-referenced application, please amend the application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims begin on page 3 of this paper.

Remarks / Arguments begin on page 7 of this paper.